

László Ágerházi

List of Publications by Year in descending order

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14
papers

76
citations

1477746

6
h-index

1473754

9
g-index

14
all docs

14
docs citations

14
times ranked

85
citing authors

#	ARTICLE	IF	CITATIONS
1	Spectroscopic quantification of the nanoparticle production efficiency of copper wire explosion. Journal of Applied Physics, 2021, 129, 195902.	1.1	2
2	Inverted fractal analysis of TiOx thin layers grown by inverse pulsed laser deposition. Applied Surface Science, 2013, 278, 106-110.	3.1	6
3	Femtosecond laser interaction with pulsed-laser deposited carbon thin films of nanoscale thickness. Applied Physics A: Materials Science and Processing, 2011, 102, 27-33.	1.1	6
4	Homogeneous films by inverse pulsed laser deposition. Applied Surface Science, 2011, 257, 5324-5327.	3.1	6
5	Thin film homogenization by inverse pulsed laser deposition. Proceedings of SPIE, 2010, , .	0.8	0
6	Thermal diffusion control of femtosecond laser generated modifications of nanoscale pulsed-laser deposited diamond-like carbon films. , 2009, , .		0
7	A point source analytical model of inverse pulsed laser deposition. Applied Physics A: Materials Science and Processing, 2008, 93, 691-696.	1.1	4
8	Inverse pulsed laser deposition. Applied Physics A: Materials Science and Processing, 2008, 93, 789-793.	1.1	6
9	High repetition rate PLD grown titanium oxide thin films. Journal Physics D: Applied Physics, 2008, 41, 085205.	1.3	6
10	Carbon nitride films of uniform thickness by inverse PLD. Applied Surface Science, 2007, 253, 8197-8200.	3.1	5
11	Atomic force microscopic characterization of films grown by inverse pulsed laser deposition. Applied Surface Science, 2006, 252, 4661-4666.	3.1	7
12	On the orientation independence of inverse pulsed laser deposition. Applied Surface Science, 2006, 252, 4656-4660.	3.1	0
13	Optical models for the ellipsometric characterization of carbon nitride layers prepared by inverse pulsed laser deposition. Applied Surface Science, 2006, 253, 173-176.	3.1	4
14	Thickness distribution of carbon nitride films grown by inverse-pulsed laser deposition. Applied Surface Science, 2005, 247, 182-187.	3.1	24